

<b>Search Notes</b> 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/538,476	REYNET ET AL.
	Examiner Shih-Chao Chen	Art Unit 2821

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
343	700MS	3/1/2006	CHEN
343	895	3/1/2006	CHEN